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PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Wook-Seong Lee	07/16/2007
Young-Joon Baik	07/16/2007
Jeung-Hyun Jeong	07/16/2007
Ki-Woong Chae	07/16/2007

RECEIVING PARTY DATA

Name:	Korea Institute of Science and Technology	
Street Address:	39-1, Hawolgok-Dong, Sungbook-Gu	
City:	Seoul	
State/Country:	KOREA, REPUBLIC OF	

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	11833679

CORRESPONDENCE DATA

Fax Number: (212)382-0888

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

Phone: 212-382-0700

Email: lcheung@ostrolenk.com

Correspondent Name: Ostrolenk, Faber, Gerb & Soffen, LLP

Address Line 1: 1180 Avenue of the Americas Address Line 4: New York, NEW YORK 10036

ATTORNEY DOCKET NUMBER: P/2292-125 (V4809)

NAME OF SUBMITTER: Max Moskowitz

Total Attachments: 1

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PATENT REEL: 019652 FRAME: 0664

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PATENT APPLICATION ASSIGNMENT - SOLE OR JOINT INVENTORS EXECUTED OUTSIDE U.S.A.

RECORDED: 08/06/2007

WHEREAS, I (We), Wook-Seong LEE & Young-Joon B	
	assigner(s), have invented certain
improvements in DC PLASMA ASSISTED CHEMICAL VAPOR DEPOS	
COLUMN, METHOD FOR DEPOSITING MATERIAL IN THE ABSENCE OF THIN LAYER THEREBY for which an application for	
been executed by me (us) of even date herewith; and	or united states Letters Patent has
been executed by me (us) or even date nerewith, and	
WHEREAS, Korea Institute of S	cience and Technology
39-1, Hawolgok-Dong, Sungbook-Gu, Seoul, Korea	
acquiring all right, title and interest in and to said	
be granted therefor.	
NOW, THEREFORE, in consideration of One valuable consideration, the receipt of which is assignor(s), hereby sell, assign and set over to said and interest for the United States and all other count the aforesaid application for Patent, all original, do or reissue applications and patents applied for or gradud all other countries, including all rights of papplication, and all rights for past infringement, and Trademarks is hereby authorized and requested to issue resulting therefrom to said assignee herein, as assign and the undersigned for myself (ourselves) and my (our assigns do hereby agree and covenant without further reall divisional, continuation, reissue and other and inventions and all assignments thereof to said assignees said assignee or its representatives all facts known inventions, whenever requested, to testify in an proceedings in which any of said applications or patent lawful papers, make all rightful oaths, and to do assist assignee, its successors, assigns and nominees said invention in the United States and all other cosaid applications to be borne and paid by said assignees.	hereby acknowledged, I (we), as d assignee the entire right, title tries in and to said invention and ivisional, continuation, substitute anted therefor in the United States priority from the filing of said and the Commissioner of Patents and a all patents on said inventions or nee of the entire interest therein; c) legal representatives, heirs and emuneration, to execute and deliver applications for Patent on said a or its assigns, to communicate to to the undersigned respecting said by interferences or other legal tes may become involved, to sign all generally everything necessary to s to obtain patent protection for puntries, the expenses incident to
Date: 16. July 2007 Date: 16. July 2007 Date: 16. July 2007	Wook-Seong LEE Young-Joon BAIK Jeung-Hyun JEONG
Date:	Ki-Woong CHAE
Date:	
LEGALIZATION RECOMMENDED	

PATENT REEL: 019652 FRAME: 0665